



JPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto HIRANO et al.

Group Art Unit: 1792

Application No.: 10/570,156

Examiner: N. FORD

Filed: March 27, 2006

Docket No.: 127194

For: SUBSTRATE TREATMENT EQUIPMENT AND MANUFACTURING METHOD OF
SUBSTRATE

RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the March 18, 2008 Restriction Requirement, please consider the
following:

Amendments to the Claims as reflected in the listing of the claims; and

Remarks.